

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE RECEIVED
CENTRAL FAX CENTER**

Applicant: Christoph A. Wasshuber

Art Unit: 2818

Serial No.: 10/714,366

Examiner: Nguyen, T.

SEP 19 2005

Filing Date: 11/13/2003

Docket No.: TI-36280

Customer No.: 23494

Conf. No.: 1864

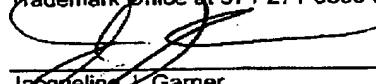
Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A
SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH
PROCESSES

AMENDMENT UNDER 37 CFR 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being
transmitted by facsimile to the U.S. Patent and
Trademark Office at 571-271-8300 on 9/19/2005.


Jacqueline J. Garner
Reg. No. 36,144

Dear Sir:

The following amendments and remarks are offered in response to the Examiner's Office Action dated 04/18/2005. They are respectfully submitted as a full and complete response to that Action.

Please amend the above-referenced application as follows:

There are no Amendments to the Specification.

Amendments to the Claims are reflected in the listing of claims that begin on page 2 of this paper.

There are no Amendments to the Drawings.

The Remarks begin on page 8.